

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/506,956
Confirmation No.: 8795
Filed: March 24, 2005
Inventor(s): Agrawal, C.M.
Title: GAS PLASMA TREATMENT
OF IMPLANTS

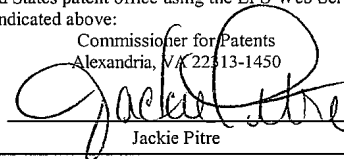
§ Examiner: David Naff
§ Art Unit: 1657
§ Atty. Dkt. No: 5660-00503
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CERTIFICATE OF ELECTRONIC FILING
UNDER 37 C.F.R. §1.8

DATE OF DEPOSIT: January 2, 2008

I hereby certify that this correspondence is being deposited with
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Alexandria, VA 22313-1450


Jackie Pitre

AMENDMENT/RESPONSE TO OFFICE ACTION MAILED JULY 2, 2007

Mail Stop: AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please amend the above-captioned application as follows:

Amendments to the Specification begin on page 2 of this paper;

Amendments to the Claims begin on page 3 of this paper; and

Remarks begin on page 8 of this paper.